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	Applicant: Hiroyuki HASHIMOTO et al.	
	Filing Date: December 27, 2004	Group Art Unit: 1637

U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Publication Date	Name	Class	Sub-Class	Filing Date

FOREIGN PATENT DOCUMENTS

Examiner Initial	Patent Number	Publication Date	Country	Class	Sub-Class	Translation
						<input type="checkbox"/> Yes <input type="checkbox"/> No
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						<input type="checkbox"/> Yes <input type="checkbox"/> No

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Papers, etc.)*

	Yu Wei, et al., "Preparation and Morphology Characterization of Solid and Functionalized Layer of Immune Molecules," Vol. 19, No. 6, pgs. 373-374 (2001) (English Translation).
	Qian Weiping, et al., "XPS and EIA Studies of Site-directed Immobilization of IgG Molecules onto Single Crystal Silicon Wafer Surfaces," No. 2, pgs. 145-150 (1999-06). (English Translation)
	Notification of the Second Office Action which was cited in a corresponding Chinese counterpart application No. 038151014, date of issue: January 9, 2009

Examiner	Date Considered
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	